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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Timothy A. Gessert

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Entitled: Ion-Beam Treatment to Prepare  
Surfaces of P-CdTe Films

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)

CERTIFICATE OF MAILING UNDER 37 CFR § 1.8

I hereby certify that the following attached items:

- (1) Amendment Under 37 CFR § 1.115 (10 pages)
- (2) Copy of Genuine Merriam-Webster definition of aperture (2 pages)
- (2) postcard receipt

are being deposited in the United States Postal Service as first class mail, postage pre-paid, in an envelope addressed to: Assistant Commissioner for Patents, Box Non-Fee Amendment, Washington, DC. 20231 on this 16th day of December 1998.

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